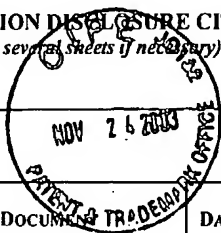


INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Docket Number (Optional) SCP-9410	Application Number 10/620,895
	Applicant(s) Akshey Seghal	
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BSC	*AB	5,013,366	05/07/1991	Jackson et al.	134	1	12/07/1988
BSC	AC	5,068,040	11/26/1991	Jackson	218	748	04/03/1989
BSC	*AD	5,313,965	05/24/1994	Palen	134	61	06/01/1992
BSC	AE	5,337,446	08/16/1994	Smith et al.	15	21.1	10/27/1992
BSC	AF	5,355,901	10/18/1994	Mielnik et al.	134	105	10/27/1992
BSC	*AG	5,377,705	01/03/1995	Smith, Jr. et al.	134	95.3	09/16/1993
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							YES	NO
BSC	BC	WO 01/33613 A2	05/10/2001	PCT	H01L	21/00		

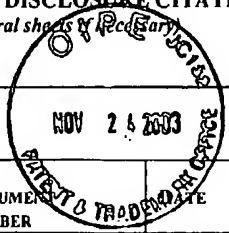
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BSC	*BD	S.B. Williams et al., "Elimination of Solvents and Waste by Using Supercritical Carbon Dioxide in Precision Cleaning," <i>Los Alamos National Laboratory LA-UR-94-3313 (1017)</i> , October 1996, 25 pages in length.
BSC	*BE	S. Verhaverbeke, "Photoresist Stripping With/Without O ₃ Assist," <i>CFM Tech</i> , in <i>Uses of Ozone in the Semiconductor Industry</i> , 19th Annual Semiconductor Pure Water and Chemical Conference, March 13, 2000, 10 pages in length.
BSC	*BF	S. Ojima et al., "Photoresist Stripping Technology Utilizing Water Vapor," 2000 Semiconductor Pure Water and Chemical Conference, 2000, pp. 387-398.

Examiner 	Date Considered 6/29/04
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

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Examiner <i>S Call</i>	Date Considered <i>6/28/04</i>
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<i>ASC</i>	CA	6,040,284	03/21/2000	Marquis et al.	510	201	05/22/1998
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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
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Examiner <i>S. Call</i>	Date Considered <i>6/24/04</i>
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	